

Docket No.: 050432-0645



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Douglas J. BONSER, et al. : Confirmation Number: 5274
Application No.: 10/791,759 : Group Art Unit: 2818
Filed: March 04, 2004 : Allowed: April 06, 2006
Examiner: Tran, Long K.

For: METHOD OF REDUCING STI DIVOT FORMATION DURING
SEMICONDUCTOR DEVICE FABRICATION

LETTER SUBMITTING FORMAL DRAWINGS

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Notice of Allowability dated April 06, 2006, submitted herewith are eleven (11) sheets of Formal Drawings in connection with the above referenced application.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Arthur J. Steiner
Registration No. 26,106

600 13th Street, N.W.
Washington, DC 20005-3096
Phone: 202.756.8000 AJS:MWE
Facsimile: 202.756.8087
Date: June 23, 2006

**Please recognize our Customer No. 20277
as our correspondence address.**